

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO
THE BOARD OF PATENT APPEALS AND INTERFERENCES (Large Entity)**

Docket No.
AM1562D1

In Re Application Of: **YIQIONG WANG**

Serial No.
09/882,141

Filing Date
June 15, 2001

Examiner
Umez-Eronini

Group Art Unit
1765

Invention: **METHOD OF ETCHING HIGH ASPECT RATIO OPENINGS IN SILICON**



TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Applicant(s) hereby appeal(s) to the Board of Patent Appeals and Interferences from the decision of the Primary Examiner dated **May 15, 2002** finally rejecting Claim(s) **1-3 and 5-6**

The fee for this Notice of Appeal is: **\$320.00**

- ☐ A check in the amount of the fee is enclosed.
- ☐ The Commissioner has already been authorized to charge fees in this application to a Deposit Account. A duplicate copy of this sheet is enclosed.
- ☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. **13-4542**
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Birgit E. Morris
Signature

Dated: **October 10, 2002**

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**Please continue to send all correspondence to
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cc: **J. Bach**

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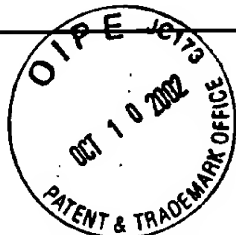
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CERTIFICATE OF MAILING BY "EXPRESS MAIL" (37 CFR 1.10) Applicant(s): YIQIONG WANG	Docket No. AM1562D1
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Serial No. 09/882,141	Filing Date June 15, 2001	Examiner Umez-Eronini	Group Art Unit 1765
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Invention: METHOD OF ETCHING HIGH ASPECT RATIO OPENINGS IN SILICON



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